

Docket Number: 081468-0352017

Client Reference: P-1755.010-US



IPW
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

FRITS JURGEN VAN HOUT, et al.

Group Art Unit: 2856

Application No.: 10/582,247

Examiner: UNASSIGNED

Filed: June 12, 2007

Confirmation No.: 2816

For: SENSOR FOR LITHOGRAPHIC APPARATUS AND METHOD OF OBTAINING
MEASUREMENTS OF LITHOGRAPHIC APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

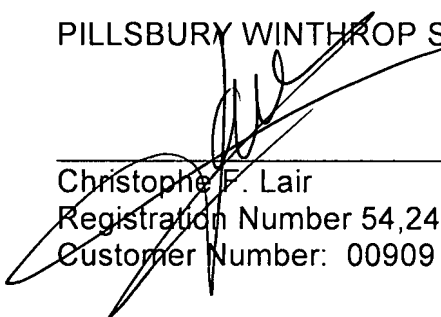
Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the reference(s) has been considered, per MPEP § 609.

This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

Respectfully Submitted,

PILLSBURY WINTHROP SHAW PITTMAN LLP

Date: October 26, 2007



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